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	Application No.	Applicant(s)	3
Notice of Allowability	10/639,942	DENNARD ET AL.	
	Examiner	Art Unit	-
	Stanetta D. Isaac	2812	
The MAILING DATE of this communication apperall claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI	(OR REMAINS) CLOSED in this or other appropriate communical IGHTS. This application is subjection.	application. If not included ion will be mailed in due c	d ourse. THIS
1. A This communication is responsive to the RCE filed on 2/16	<u>3/05</u> .		
2. The allowed claim(s) is/are <u>1-19</u> .			
 3. ☐ Acknowledgment is made of a claim for foreign priority ur a) ☐ All b) ☐ Some* c) ☐ None of the: 1. ☐ Certified copies of the priority documents have 			
Certified copies of the priority documents have			
Copies of the certified copies of the priority does not be certified.	• •		on from the
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		oly complying with the requ	uirements
4. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give			TICE OF
 CORRECTED DRAWINGS (as "replacement sheets") must (a) ☐ including changes required by the Notice of Draftspers 1) ☐ hereto or 2) ☐ to Paper No./Mail Date (b) ☐ including changes required by the attached Examiner's 	son's Patent Drawing Review (PT	,	
Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1.	.84(c)) should be written on the dra	wings in the front (not the b	eack) of
each sheet. Replacement sheet(s) should be labeled as such in the feet of the sheet	sit of BIOLOGICAL MATERIA	L must be submitted. No	ote the
Attachment(s) 1. ☑ Notice of References Cited (PTO-892)	5. ☐ Notice of Informa	l Patent Application (PTO	152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview Summa	ary (PTO-413),	
3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date <u>2/16/05</u>			
 Examiner's Comment Regarding Requirement for Deposit of Biological Material 	8. 🖂 Examiner's State	ment of Reasons for Allow	ance
-	9. Other		ff.
		MAN LOUNG	
		HAEL LEBENTRITT ORY PATENT EXAMINI	ER

EXAMINER'S AMENDMENT/COMMENTS

An examiner's amendment/comments to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Continued Examination Under 37 CFR 1.114

A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after allowance or after an Office action under *Ex Parte Quayle*, 25 USPQ 74, 453 O.G. 213 (Comm'r Pat. 1935). Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, prosecution in this application has been reopened pursuant to 37 CFR 1.114. Applicant's submission filed on 2/16/05 has been entered.

Information Disclosure Statement

The information disclosure statement (IDS) was submitted on 2/16/05 was filed after the mailing date of the Office Action on 12/07/04. The submission is in compliance with the provisions of 37 CFR 1.97. Accordingly, the information disclosure statement is being considered by the examiner.

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REASONS FOR ALLOWANCE

The following is an examiner's statement of reasons for allowance:

The closest prior art of record, Chan et al., US Patent 6,580,132, fails to show the following steps:

Pertaining to independent claim 1, "forming undercutting shallow trench isolation regions in said structure, wherein during said forming of said undercutting shallow trench isolation regions the back-gate is etched to a length which is less than a length of the overlying Sicontaining layer, yet aligned to a lateral edge of said front polySi gate;"

Pertaining to independent claim 19, "forming undercutting shallow trench isolation regions in said structure by the steps of chemical etching, isotropic reactive ion etching, oxidation and a second isotropic etch;"

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Stanetta D. Isaac whose telephone number is 571-272-1671. The examiner can normally be reached on Monday-Friday 9:30am -6:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Michael Lebentritt can be reached on 571-272-1873. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Stanetta Isaac Patent Examiner October 30, 2005

MICHAEL LEBENTRITT
SUPERVISORY PATENT EXAMINER

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